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APPLICANTS

Sung Hoon Lee, Seoul, KOREA, REPUBLIC OF;

** CONTINUING DATA ***** NONE LV

** FOREIGN APPLICATIONS ***** YES LV
 REPUBLIC OF KOREA 2002-68678 11/07/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature: <i>[Signature]</i> Initials: <i>LV</i>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 4	TOTAL CLAIMS 11	INDEPENDENT CLAIMS 1
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TITLE
 Method of forming an isolation film in a semiconductor device

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